



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: YOSHIDA, AKITO DOCKET NO.: W2K1077  
SERIAL NO: 10/082,472 EXAMINER: ZARNEKE  
FILED: 02/22/2002 ART UNIT: 2827  
TITLE: A STACKING STRUCTURE FOR SEMICONDUCTOR DEVICES  
USING A FOLDED OVER FLEXIBLE SUBSTRATE AND METHOD  
THEREFOR

Mail Stop: Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Weiss, Moy & Harris, P.C.  
4204 N. Brown Avenue  
Scottsdale, AZ 85251-3989

February 4, 2004

I hereby certify that on the 4<sup>th</sup> day of February, 2004,  
this correspondence is being deposited with the U.S.  
Postal Service as first class mail in an envelope  
addressed to: Commissioner for Patents, P.O. Box 1450  
Alexandria, VA 22313-1450.

  
Jeffrey D. Moy

**DRAFT AMENDMENT**

Dear Sir:

This is in response to the Office Action dated October  
10, 2003 in regards to the above identified patent application.  
Please amend the subject patent application as follows: